



2829
PATENT
Customer No. 22,852
Attorney Docket No. 04329.2688

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Miyoko SHIMADA, et al.) Group Art Unit: 2829
)
Serial No.: 09/982,003) Examiner: Kilday, Lisa A.
)
Filed: October 19, 2001)
)
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

TRANSMITTAL LETTER

Enclosed is a reply to the Office Action of June 18, 2003. The items checked below are appropriate:

- ☐ Applicants hereby petition for a month extension of time to respond to the above Office Action. The fee of \$ for the Extension is enclosed.

The claims are calculated below:

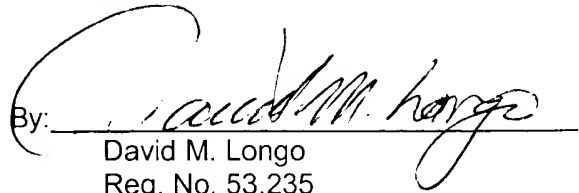
| | Claims Remaining After Amendment | | Highest Number Previously Paid | Present Extra | Rate | Additional Fee |
|---|-------------------------------------|---|-----------------------------------|------------------|---------|-------------------|
| Total | 27 | - | 26 | 1 | x \$ 18 | \$ 18.00 |
| Indep. | 3 | - | 3 | 0 | x \$ 84 | 0.00 |
| <input type="checkbox"/> First Presentation of Multiple Dep. Claim(s) | | | | | +\$280 | 0.00 |
| Subtotal | | | | | | \$ 18.00 |
| Reduction by 1/2 if small entity | | | | | | - 0.00 |
| TOTAL | | | | | | \$ 18.00 |

- ☒ A fee of \$18 to cover the cost of the additional claims added by this reply is enclosed.
- ☐ A fee of \$ to cover is enclosed.
- ☐ A check for \$18 to cover the above fee is enclosed.

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1300 I Street, NW
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Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Dated: September 22, 2003

By: 
David M. Longo
Reg. No. 53,235

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Sir:

AMENDMENT

In reply to the Office Action of June 18, 2003, with a period for response extending through September 22, 2003 (due to Federal Government closure on September 18 and 19, 2003 because of Hurricane Isabel, September 20, 2003 being a Saturday, and September 21, 2003 being a Sunday), please amend the application as follows. Applicants also respectfully request the Examiner's reconsideration in view of the remarks that follow:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.

Remarks begin on page 10.

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